

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Maud Vinet et al.
SERIAL NO.: 10/539,532
FILING DATE: June 17, 2005 CONFIRMATION No.: 4554
TITLE: Method For Forming Patterns Aligned On Either Side Of A Thin Film
EXAMINER: Chen, Kin Chan
TELEPHONE: (571) 272-1461
FAX: (571) 273-8300
ART UNIT: 1792

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE AFTER FINAL OFFICE ACTION UNDER

37 CFR 1.116

Dear Sir:

This paper is responsive to the Advisory Action mailed April 30, 2008. Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page **2** of this paper.

Remarks begin on page **5** of this paper.